

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :
Jung-Hwan Oh et al. :
Serial No.: NEW : Group Art Unit: TBD
Filed: 20 October 2003 : Attorney Docket No.: SEC.926
For: ONE-CYLINDER STACK CAPACITOR AND METHOD FOR FABRICATING
THE SAME

CLAIM OF PRIORITY

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Patent Application**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Applicants, in the above-identified application, hereby claim the priority date
under the International Convention of the following Korean application:

Appln. No. 2001-78286 filed December 11, 2001

as acknowledged in the Declaration of the subject application.

A certified copy of said application was filed in the parent application.

Respectfully submitted,

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Date: 20 October 2003

대한민국 특허청
KOREAN INTELLECTUAL
PROPERTY OFFICE

별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto
is a true copy from the records of the Korean Intellectual
Property Office.

출원 번호 : 특허출원 2001년 제 78286 호
Application Number PATENT-2001-0078286

출원 년 월 일 : 2001년 12월 11일
Date of Application DEC 11, 2001

출원 인 : 삼성전자 주식회사
Applicant(s) SAMSUNG ELECTRONICS CO., LTD.



2002 년 05 월 07 일

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